

Docket No.: 42390P10254

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

VALERY M. DUBIN, ET AL.

Application No.: 09/753,256

Filed: December 28, 2000

For: INTERCONNECT STRUCTURES AND A

METHOD OF ELECTROLESS

INTRODUCTION OF INTERCONNECT

STRUCTURES

Art Group: 2813

Examiner: Nguyen, Tuan H.

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INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted within three (3) months of filing of the application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s). Copies of the references cited on PTO/SB/08 are enclosed herewith.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: $\frac{7/21/03}{}$

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I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Date

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet of 1

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| Application Number | 09/753,256 | |
| Filing Date December 28, 2000 | | |
| First Named Inventor | Valery M. Dubin | |
| Art Unit 2813 | | |
| Examiner Name | Nguyen, Tuan H. | |
| Attorney Docket Number | 42390P10254 | |

| OTHER ART - NON PATENT LITERATURE DOCUMENTS | | | | |
|---|--------------|---|------|--|
| Examiner Initials* | Cite No.1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T² | |
| | | Dubin, et al., "Selective Electroless Ni Deposition onto Pd-Activated Si for Integrated Circuit Fabrication," Thin Solid Films, 226, 1993, pp. 94-98 | | |
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Based on PTO/SB/08B (05-03) as modified by Blakely, Solokoff, Taylor & Zafman (wir) 05/02/2003. Send To: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.